

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Shinji MAEKAWA et al.)
)
Serial No.: 10/827,457)
)
Filed: April 19, 2004)
)
For: Method For Forming Pattern And)
Drop Discharge Apparatus)
)
Examiner: Marianne L. Padgett)
)
Art Unit: 1715)
)
Confirmation No.: 2984)

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT L

Applicants have the following response to the Office Action of February 16, 2011, a one month extension of time being submitted herewith.

Please amend the above-identified application as follows: